

8/25/2003

<b>INFORMATION DISCLOSURE CITATION IN AN APPLICATION</b>  (Use several sheets if necessary)	Attorney Docket No.: <b>8008-1046</b>	Application No.: <b>NEW NONPROVISIONAL</b>
	Applicant: <b>Shin-ichi UEHARA et al.</b>	
	Filing Date: <b>August 25, 2003</b>	Group Art Unit:

### U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing date (if appropriate)

### FOREIGN PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
RLO	8-68961	3/12/1996	JAPAN				
RLO	4-112273	4/14/1992	JAPAN				
RLO	9-197343	7/31/1997	JAPAN				

### OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

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EXAMINER: 	DATE CONSIDERED <b>12/22/05</b>
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

\* Abstract provided for the Examiner's convenience

FORM PTO-1449 U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICE

ATTY. DOCKET NO.  
8008-1046

SERIAL NO.  
10/646,799

**INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT**

(Use several sheets if necessary)

37 CFR 1.98(b)

MAR 02 2004

APPLICANT  
UEHARA et al.

FILING DATED  
August 25, 2003

GROUP  
2671

**PATENT DOCUMENTS**

EXAMINER INITIAL		PATENT NUMBER	ISSUE DATE	PATENTEE	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
RLO	AA	5,825,541	10/20/98	IMAI			
	AB	5,500,765	3/19/96	EICHENLAUB			
	AC	5,982,342	11/9/99	IWATA et al.			
	AD	6,157,242	12/5/00	FUKUI			

**FOREIGN PATENT OR PUBLISHED FOREIGN PATENT APPLICATION**

		DOCUMENT NO.	PUBL. DATE	COUNTRY OR PATENT OFFICE	CLASS	SUB CLASS	TRANSLATION YES NO
RLO	AI	EP 0 829 744 A2	3/18/98	EP			
RLO	AJ	2001-258051	9/21/01	JAPAN			
	AK						
	AL						
	AM						
	AN						
	AO						
	AP						
	AQ						

**OTHER DOCUMENTS (Including Author, Title, Date, Relevant Pages, Place of Publication)**

RLO	AT	PATENT ABSTRACTS OF JAPAN, vol. 2000, no. 26, July 1, 2002, JP 2001 258051 A
	AU	
	AV	
	AX	
	AY	

EXAMINER

*Richard Garcia*

DATE CONSIDERED

*12/22/05*

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